

The effects of device geometry and TCO/Buffer layers on damp heat accelerated lifetime testing of Cu(In,Ga)Se₂ solar cells

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Introduction and Motivation

- CIGS cells are moisture sensitive. Modeling studies [1,2] suggest that module encapsulation with water vapor transmission rate (WVTR) of 10^{-4} to 10^{-6} g-H₂O/m²-day is needed for lifetime > 20 yrs
- Damp Heat (D-H) accelerated lifetime testing (ALT) at 85%RH/85°C performed at IEC on CIGS cells encapsulated with a glass or PET top sheet.
- WVTR of PET ~10g/m²-day >>> greater than WVTR of glass (<< 10^{-6} g/m²-day)
- Glass and PET sample degraded at the same rate. Why? Was it related to device structure?

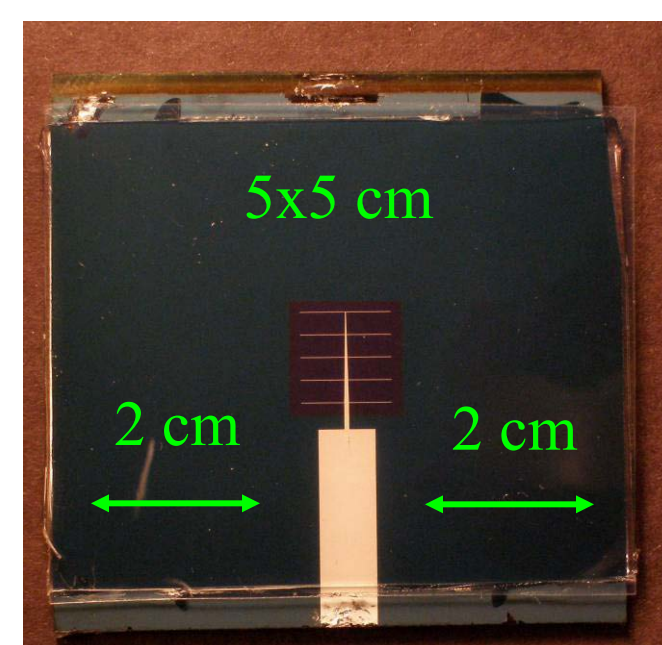
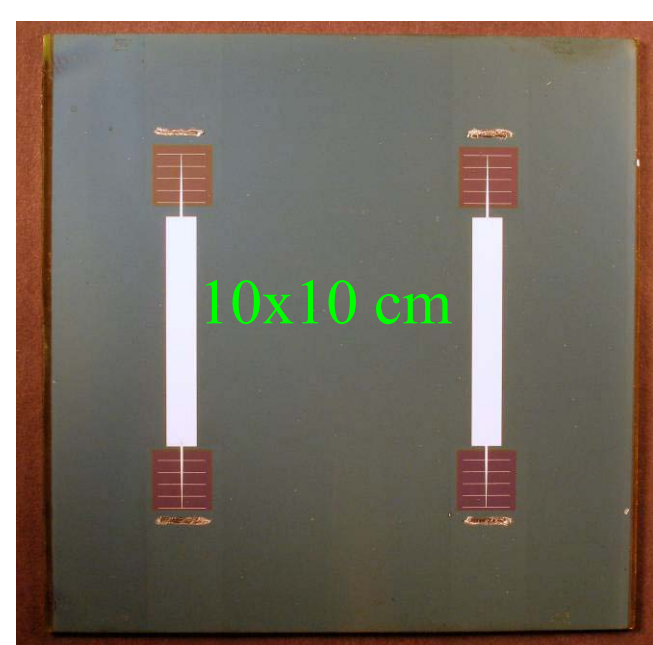
Approach

- Devices (SL/Mo/CIGS/CdS/i-ZnO/ITO/Ni-Al grids) on glass with different encapsulation schemes:
 - ❑ 6 pieces with PET, unscribed
 - ❑ 6 pieces with glass, unscribed
 - ❑ PET and glass top sheet bonded to cell with commercial thermoplastic encapsulant
 - ❑ 3 Control pieces, un-encapsulated, 6 cells each, scribed
- Use IEC's CIGS baseline process with variation in cell patterning and i-ZnO integrity (i.e. scribing)
- Subject to D-H ALT for 2000 hrs under ~1 sun illumination, Voc.
- I-V characterization at regular intervals

Device Layout

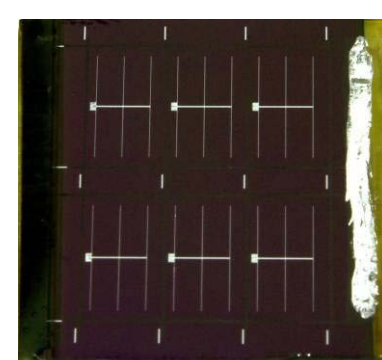
Layout # 1:
1 cm² devices, defined by ITO masking, no scribing, i-ZnO blanket deposition to the edge of substrate

- 4 devices (1 cm²) fabricated on a 10x10 cm substrate, no scribing
- Cut into four coupons, 1 cell each



Layout # 2: 0.47 cm² scribed devices

- 1"x1" substrates comprised of 6 unencapsulated devices ('bare')



Experimental Setup

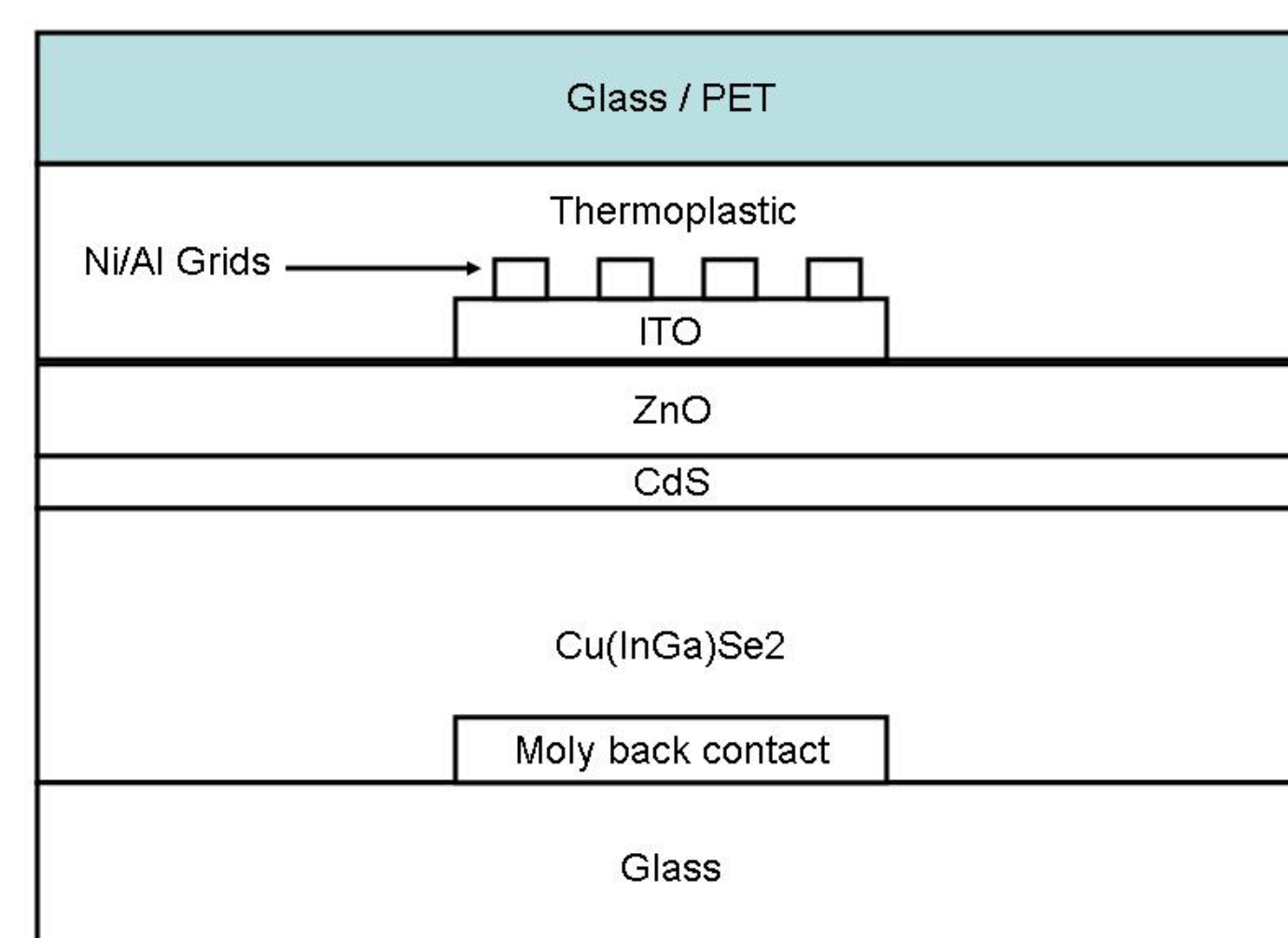
Unique Environmental Chamber

- Metal halide lamp ~1sun illumination intensity
- Electrical contacts allow illumination monitoring and in-situ device testing



Device Structure: Layout #1

- Molybdenum back contact patterned to extend from device to edge of glass (reduces shunting)
- CIGS deposited on glass/Mo using multisource evaporation: EG ~ 1.2 eV, thickness ~ 2 μm
- CdS from CBD thickness: ~50 nm
- Intrinsic ZnO: ~50 nm, sputtered on entire area
- ITO: 150 nm, sputtered through mask, defines cell
- Ni/Al grids e-beamed through mask



- ITO: $R_{\square} = 27\Omega/\square$; i-ZnO: $R_{\square}$ -insulating
- Molybdenum back contact and Ni/Al front contacts run to edge of 5x5 cm substrate
- Encapsulation: 5 mil sheet of PET or glass lid
- Bonding: industrial grade thermoplastic applied at 150°C under pressure

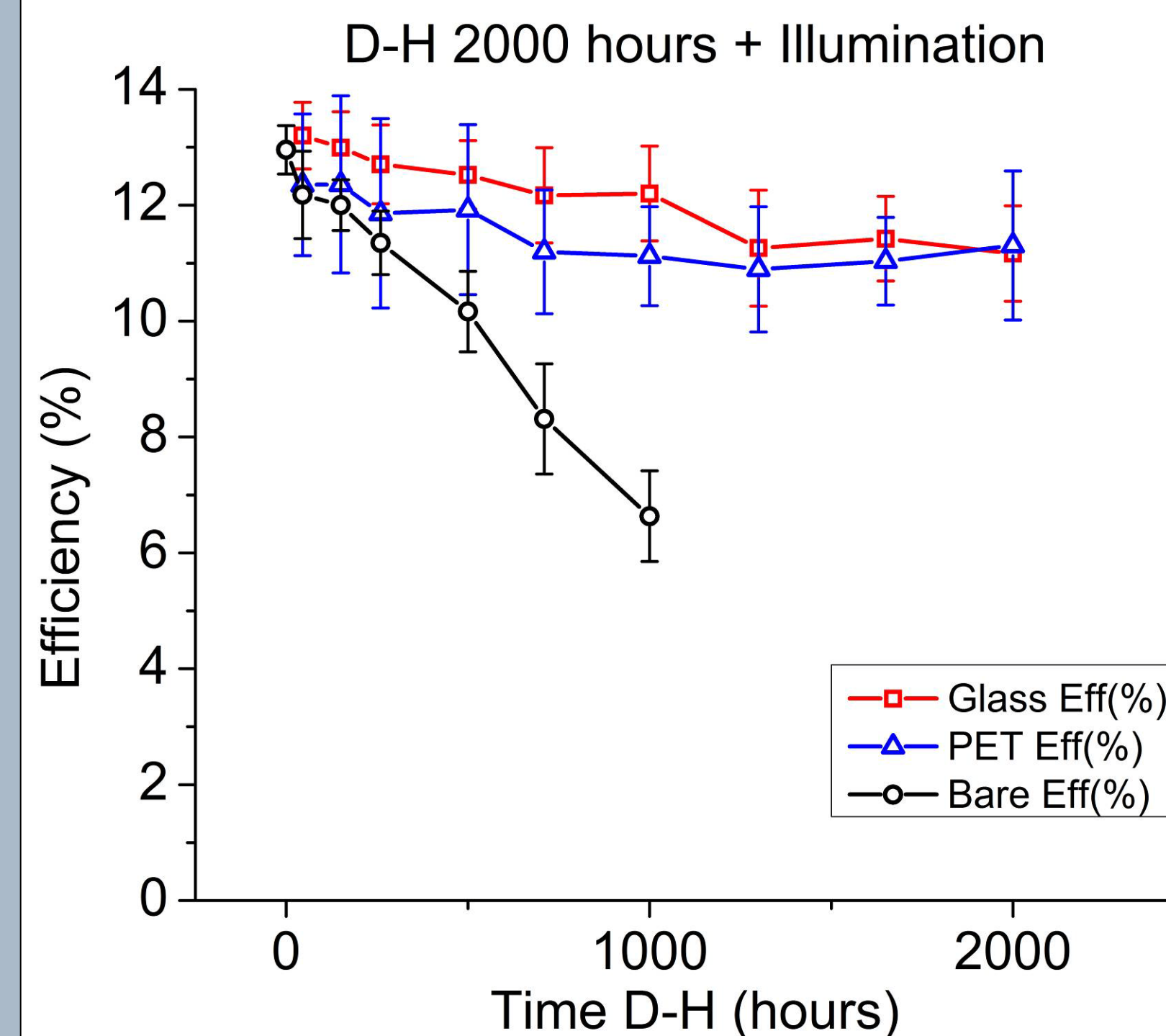
Device Structure: Layout #2

- Same as above except i-ZnO/ITO sputtered over entire 1x1 inch substrate, cell area defined by scribing
- No encapsulation

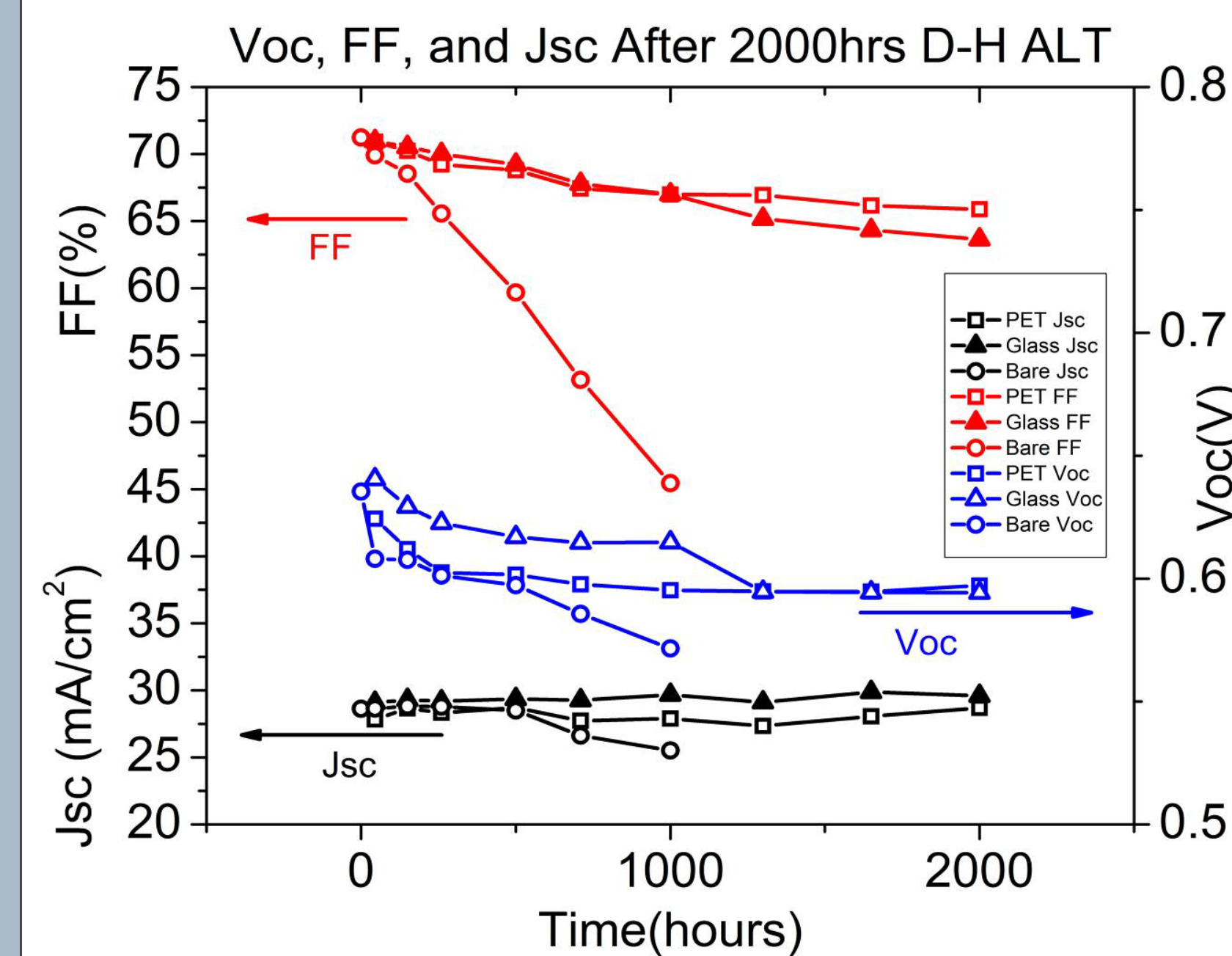
Test Results from D-H ALT

Efficiency for 2000 hours of illuminated D-H

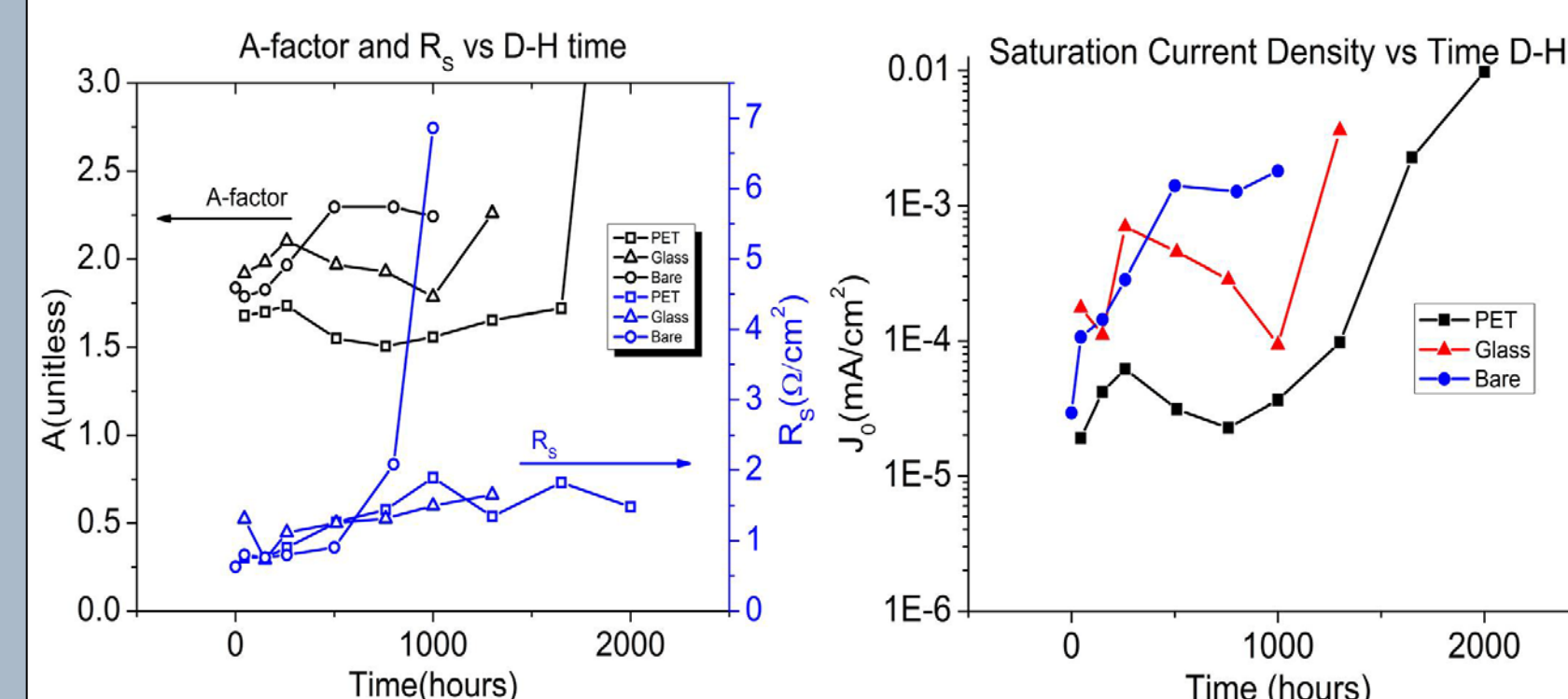
- Layout #1: Average of 6 devices each glass or PET
- Layout #2: average of 18 devices, bare, scribed



- Glass and PET devices retain 92% initial efficiency after 2000 hours D-H despite very different WVTR
- Bare samples degrade to 52% original eff at 1000 hours, similar to PET samples in previous study [3]



- Degradation: FF most, Voc some, Jsc negligible



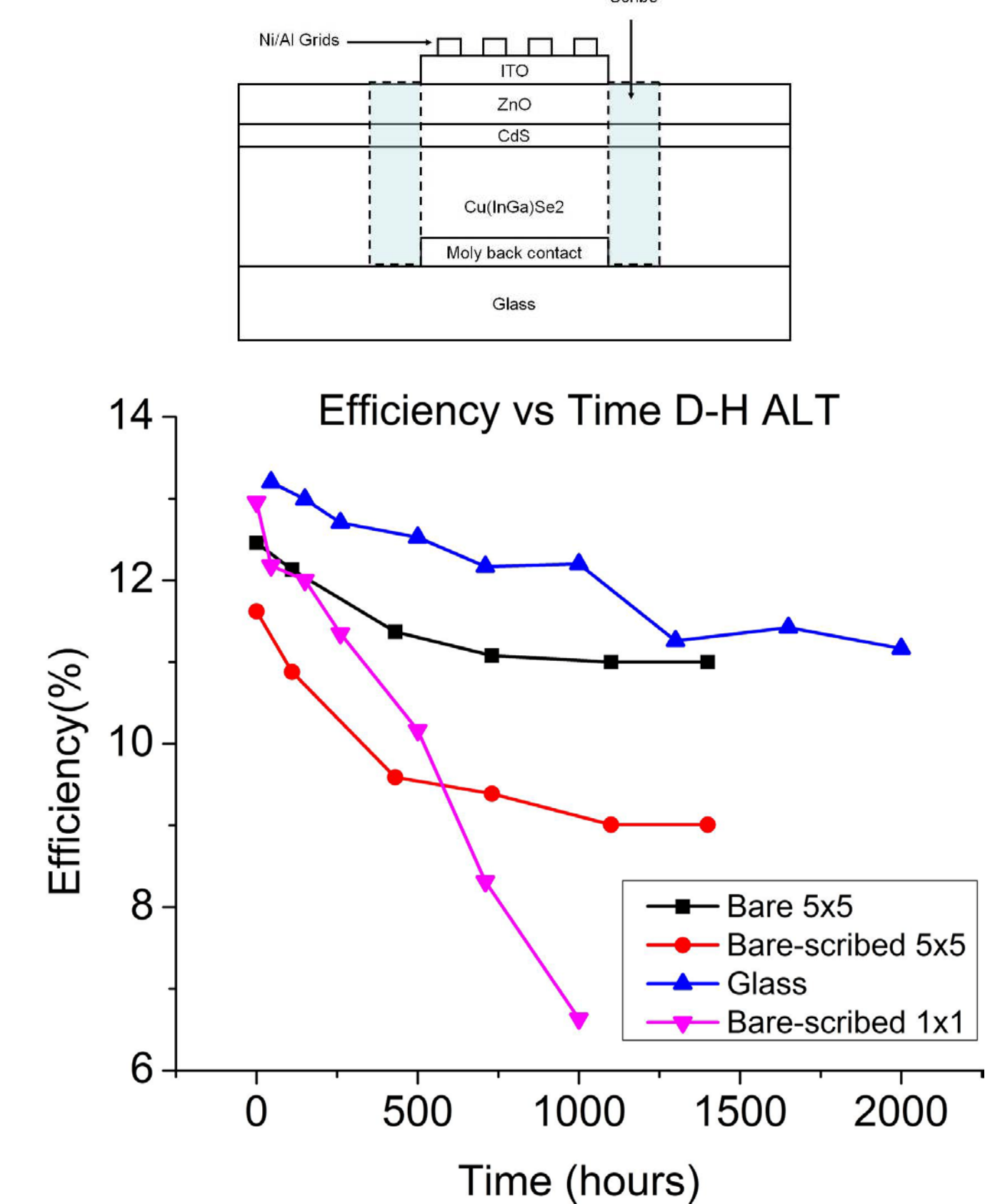
- All show increase of A and J₀ but 'bare' has largest
- All show small but steady increase in R_s
- At 500 hrs, large increase in R_s for 'bare' scribed

Effects of scribes on D-H degradation

- In [3] i-ZnO deposited through a 1x1cm mask
- Now over entire 5x5cm area (improved thermoplastic bonding adhesion)
- Two experiments to evaluate effect of i-ZnO
 - ❑ Measure WVTR of i-ZnO, ITO and i-ZnO/ITO stack
 - ❑ Two 5x5 cm samples for D-H ALT, no encapsulation or capping layer.
- Layout #3: same as #1, except area defined by scribe, no capping layer 'bare 5x5'

Layout #4: same as #1, no capping layer, unscribed

- 1400 hrs D-H ALT in the dark



- 'Bare 5x5' as stable as PET or glass encapsulated
- 'Bare scribed 5x5' degraded like 'bare' until ~600 hours, and leveled out

- ❑ Possibly due to ratio of scribe length to device area
- ❑ Possible illuminated vs dark D-H effect

Conclusions and References

- TCO and buffer layers can harden CIGS cells to D-H conditions, up to 2000 hrs
- Scribe lines that provide water vapor a direct path to CIGS/CdS junction shorten device D-H lifetime
- With a WVTR of 2E-3 g/m²-day, a i-ZnO/ITO stack is an effective water vapor barrier

References

- [1] M. D. Kempe, Modeling of rates of moisture ingress into photovoltaic modules, Solar Energy Mater. & Solar Cells 90 (2006) 2720-2738.
- [2] D. J. Coyle, H.A. Blaydes, J. E. Pickett, R. S. Northey, and J. O. Gardner, Degradation kinetics of CIGS solar cells, in Proceedings of the 35th IEEE Photovoltaics Specialists Conference (2009).
- [3] P.F. Carcia, R.S. McLean, Steven Hegedus, Encapsulation of Cu(InGa)Se₂ solar cell with Al₂O₃ thin-film moisture barrier grown by atomic layer deposition, Solar Energy Materials & Solar Cells 94 (2010) pp. 2375-2378